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APPLICATION NO.	FII	LING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/727,526	1	2/05/2003	Masahiro Fushimi	03560.003415. 7334	
5514	7590	10/11/2005	EXAMINER		
FITZPATR 30 ROCKE		LA HARPER & S	SANTIAGO, MARICELI		
NEW YORK, NY 10112			ART UNIT	PAPER NUMBER	
				2879	

DATE MAILED: 10/11/2005

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)			
	10/727,526	FUSHIMI, MASAHIRO			
Office Action Summary	Examiner	Art Unit			
	Mariceli Santiago	2879			
The MAILING DATE of this communication app Period for Reply	ears on the cover sheet with the c	orrespondence address			
A SHORTENED STATUTORY PERIOD FOR REPLY WHICHEVER IS LONGER, FROM THE MAILING DA - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. - If NO period for reply is specified above, the maximum statutory period w - Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	ATE OF THIS COMMUNICATION 16(a). In no event, however, may a reply be tim rill apply and will expire SIX (6) MONTHS from a cause the application to become ABANDONEI	L. ely filed the mailing date of this communication. O (35 U.S.C. § 133).			
Status					
Responsive to communication(s) filed on This action is FINAL . 2b)⊠ This Since this application is in condition for allowan closed in accordance with the practice under E.	action is non-final. ice except for formal matters, pro				
Disposition of Claims					
4) ☐ Claim(s) 1-9 is/are pending in the application. 4a) Of the above claim(s) is/are withdraw 5) ☐ Claim(s) is/are allowed. 6) ☐ Claim(s) 1-3 is/are rejected. 7) ☐ Claim(s) 5-9 is/are objected to. 8) ☐ Claim(s) are subject to restriction and/or					
Application Papers					
9) The specification is objected to by the Examiner 10) The drawing(s) filed on <u>05 December 2003</u> is/ar Applicant may not request that any objection to the of Replacement drawing sheet(s) including the correction to the other control of the correction of the correction of the other control of the correction of the other control of the correction of the correction of the other control of the correction of	re: a) \square accepted or b) \square objected frawing(s) be held in abeyance. See on is required if the drawing(s) is object.	e37 CFR 1.85(a). ected to. See 37 CFR 1.121(d).			
Priority under 35 U.S.C. § 119					
 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. 					
Attachment(s) 1) Notice of References Cited (PTO-892) 2) Notice of Draftsperson's Patent Drawing Review (PTO-948) 3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date 7/15/2004.	4) Interview Summary (Paper No(s)/Mail Da 5) Notice of Informal Pa 6) Other:				

DETAILED ACTION

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.

Claims 1-3 are rejected under 35 U.S.C. 102(b) as being anticipated by Nomura et al. (US 5,828,352).

Regarding claim 1, Nomura discloses an image forming apparatus (Figs. 13-14) comprising an electron-source substrate (1) having a plurality of cold-cathode electron emitting elements (5), each having an electron emitting portion (4) and a pair of element electrodes (3a, 3b), an acceleration electrode (7) for applying an acceleration voltage operating on electrons emitted from the electron emitting elements, disposed so as to face the electron emitting elements, a spacer (10) disposed between the electron-source substrate and the acceleration electrode, a wiring portion (17a, 17b) formed on the electron-source substrate for driving the electron emitting elements, these components being accommodated within an envelope, and an electron-trajectory correcting electrode (18b) for correcting beam deviation due to charging of the spacer, provided near an electron emitting element near the spacer.

Regarding claim 2, Nomura discloses an image forming apparatus (Figs. 13-14) comprising an electron-source substrate (1) having a plurality of electron emitting elements (5), an acceleration electrode (7) for applying an acceleration voltage operating on electrons emitted from the electron emitting elements, disposed so as to face the electron emitting elements, a spacer (10) disposed between the electron-source substrate and the acceleration electrode, a wiring portion (17a, 17b) formed on the electron-source substrate for driving the electron

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emitting elements, these components being accommodated within an envelope, and an electron-trajectory correcting electrode (18b) for defecting a trajectory of electrons emitted from an electron emitting element closest to the spacer so as to be separated from the spacer, disposed on the electron-source substrate in a state of being separated from the spacer.

Regarding claim 3, Nomura discloses an image forming apparatus (Figs. 13-14) wherein the electron-trajectory correcting electrode is disposed on a surface of the electron-source substrate where the electron emitting elements are disposed.

Claim 1 is rejected under 35 U.S.C. 102(b) as being anticipated by Yamazaki et al. (US 6,351,005).

Regarding claim 1, Yamazaki discloses an image forming apparatus (Fig. 7) comprising an electron-source substrate (31) having a plurality of cold-cathode electron emitting elements (111), each having an electron emitting portion (1113) and a pair of element electrodes (1103, 1102), an acceleration electrode (1019) for applying an acceleration voltage operating on electrons emitted from the electron emitting elements, disposed so as to face the electron emitting elements, a spacer (20) disposed between the electron-source substrate and the acceleration electrode, a wiring portion (13) formed on the electron-source substrate for driving the electron emitting elements, these components being accommodated within an envelope, and an electron-trajectory correcting electrode (21) for correcting beam deviation due to charging of the spacer, provided near an electron emitting element near the spacer.

Allowable Subject Matter

Claims 4-9 are objected to as being dependent upon a rejected base claim, but would be allowable if rewritten in independent form including all of the limitations of the base claim and any intervening claims.

The following is a statement of reasons for the indication of allowable subject matter:

Regarding claim 4, the references of the Prior Art of record fails to teach or suggest the combination of the limitations as set forth in claim 4, and specifically comprising the limitation the electron-trajectory correcting electrode is disposed on the wiring portion.

Regarding claim 5, the references of the Prior Art of record fails to teach or suggest the combination of the limitations as set forth in claim 5, and specifically comprising the limitation of the spacer is disposed for each of the plurality of lines, and the electron-trajectory correcting electrode is disposed between the spacer and one of the plurality of lines closest to the spacer.

Regarding claims 6 and 7, claims 6 and 7 are allowable for the reasons given in claim 5 because of their dependency status from claim 5.

Regarding claim 8, the references of the Prior Art of record fails to teach or suggest the combination of the limitations as set forth in claim 8, and specifically comprising the limitation of the spacer is disposed for each of the plurality of lines, and the electron-trajectory correcting electrode is disposed, so as to sandwich the spacer and one of the plurality of lines closest to the spacer.

Regarding claim 9, claim 9 is allowable for the reasons given in claim 8 because of its dependency status from claim 8.

Contact Information

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Mariceli Santiago whose telephone number is (571) 272-2464. The examiner can normally be reached on Monday-Friday from 9:30 AM to 6:00 PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Nimesh Patel, can be reached on (571) 272-2457. The fax phone number for the organization where this application or proceeding is assigned is (571) 273-8300.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Mariceli Santiago Primary Examiner Art Unit 2879